

PATENT 4450-0235P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Niakam KAZEMI

Conf.:

5195

Appl. No.:

09/827,994

Group:

2173

Filed:

April 6, 2001

Examiner: NGUYEN, Cao H.

For:

DEFECT MANAGEMENT SYSTEM AND METHOD

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LARGE ENTITY TRANSMITTAL FORM

Technology Center 2100

June 9, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Reply in the above-identified application.

The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.

The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

| | CLAIMS REMAINING AFTER AMENDMENT | | HIGHEST NUMBER PREVIOUSLY PAID FOR | | PRESENT EXTRA | RATE | additional FEE |
|--|---|-----|---|---|------------------|-------|-------------------|
| TOTAL | 36 | _ | 36 | = | 0 | \$ 18 | \$0.00 |
| INDEPENDENT | . 3 | - | 3 | = | 0 | \$ 86 | \$0.00 |
| FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM | | | | | | \$290 | \$0.00 |
| | | · · | | | | TOTAL | \$0.00 |

(Rev. 02/08/2004)

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in the

Attachment(s)

| | Petition for () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time. |
|----------------|--|
| \boxtimes | No fee is required. |
| | Check(s) in the amount of \$0.00 is(are) enclosed. |
| | Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate. |
| overn requ: | If necessary, the Commissioner is hereby authorized in this, arrent, and future replies, to charge payment or credit any payment to Deposit Account No. 02-2448 for any additional fees ired under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; icularly, extension of time fees. |
| | Respectfully submitted, |
| | BIRCH, STEWART, KOLASCH & BIRCH, LLP |
| | By Michael R. Cammarata, #39,491 |
| MRC/} | P.O. Box 747 Kpc Falls Church, VA 22040-0747 (703) 205-8000 |



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REPLY UNDER 37 C.F.R. § 1.111

Technology Center 2100

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 June 9, 2004

Sir:

In reply to the Office Action dated March 29, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes Remarks.